



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Hyungjun KIM et al.

CONFIRM. NO. 3395

SERIAL NO.: 10/699,226

ART UNIT: 1762

FILED: 10/31/2003

EXAMINER: Bret P. CHEN

TITLE: PLASMA ENHANCED ALD OF TANTALUM NITRIDE AND BILAYER

ATTORNEY DOCKET NO.: YOR920030208US1

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. 1.116

Responsive to the final Office Action of May 31, 2006,
please reconsider this application in view of the
following:

Listing of and Amendments to Claims Page 2

Remarks Page 6

Certificate of Mailing

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deposited with the United States Postal Service as first
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August 31, 2006
Date

David Chen
Name of Person Making Deposit